## In the Specification:

Please amend paragraph 1 on page 1 as follows:

The present application is related to U.S. Patent Application No. 09/876.967—/

(Attorney Docket No. CISCP217) by Shen et al., and titled Methods and Apparatus for Updating a Reduction Ratio and related to U.S. Patent Application No. 6.763.070—/ (Attorney Docket No. CISCP234) by Lee et al., and titled Methods and Apparatus for Selecting a Cut-off index, both filed on the same day as the present application. Each of the above patent applications is incorporated herein by reference for all purposes.

Appln. No.: 09/867,966 Atty Docket: CISCP219/4103